



10110-3:DEN:221224

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:)
) Before the Examiner
Hiromichi Ohta, et al.)
) Jennifer C. McNeil
Application No. 09/615,883)
) Group Art Unit 1775
Filed July 14, 2000)
) May 27, 2003
LOW-RESISTANCE ITO)
THIN FILM AND METHOD)
FOR MANUFACTURING)
SUCH A FILM)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Commissioner for Patents, Alexandria, VA 22313-1450 on

May 27, 2003

Date of Deposit

David E. Novak

Name of Registered Representative

David E. Novak

Signature

May 27, 2003

Date of Signature

AMENDMENT AND RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 27, 2002, please enter the following amendments and consider the following remarks.

Applicant requests a three month extension of time for responding to the present Office Action and encloses the request and required fee pursuant to 37 C.F.R. §1.17. No additional fees are believed to be due. However, if any fees are deemed necessary please charge said fees to Deposit Account No. 23-3030, but do not include any payment of issue fees.